



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 10, 2026	
IGI Report Number	LG816657740
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE MIXED CUT
Measurements	7.87 X 7.84 X 5.16 MM

GRADING RESULTS

Carat Weight	3.02 CARATS
Color Grade	G
Clarity Grade	VVS 2

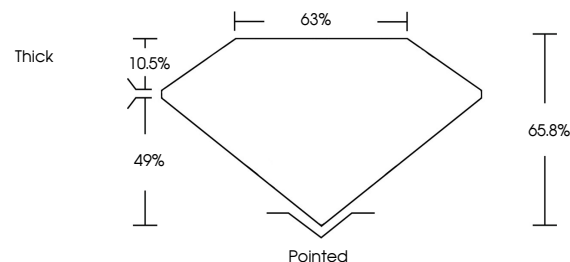
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	131 LG816657740

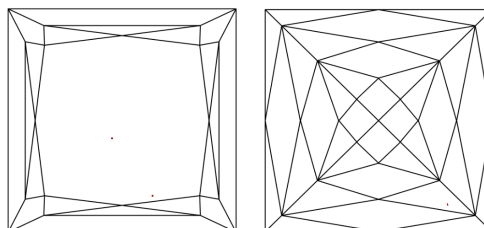
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG816657740
Report verification at igi.org

PROPORTIONS

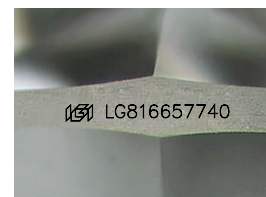


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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July 10, 2026
 GI Report No LG816657740
 SQUARE MIXED CUIT

3.02 CARATS	G	VVS 2	65.0%	68%	Thick	Pointed	EXCELLENT	EXCELLENT	NONE
Carat Weight	Color Grade	Clarity Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence

Comments:
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www.igi.org